



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Potyrailo et al.

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Art Unit: Not Yet Known

For: METHODS FOR DEPOSITION
OF SENSOR REGIONS ONTO OPTICAL
STORAGE MEDIA SUBSTRATES AND
RESULTING DEVICES

Dated: February 5, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CHANGE OF CORRESPONDENCE ADDRESS IN APPLICATION

Please send all future correspondence for this application to:

GE Global Research
Docket Room K-1/4A59
One Research Circle
Niskayuna, New York 12309

Respectfully submitted,

Raymond E. Farrell
Reg. No. 34,816
Attorney for Applicant(s)

Raymond E. Farrell, Esq.
CARTER, DELUCA, FARRELL & SCHMIDT, LLP
445 Broad Hollow Road – Suite 225
Melville, New York 11747
(631) 501-5700
REF:jrv

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 5, 2004.

Dated: February 5, 2004

Jennifer Vitale